	•	917
Application No.	Applicant(s)	
10/580,462	LEE ET AL.	
Examiner	Art Unit	
Hoang V. Nguyen	2821	
(OR REMAINS) CLOSED in the or other appropriate community	nis application. If not include ication will be mailed in due of	d course. THIS
<u> 25/05</u> .		
	(f) .	
cuments have been received in	n this national stage applicat	ion from the
of this communication to file a IENT of this application.	reply complying with the req	uirements
itted. Note the attached EXAMes reason(s) why the oath or d	IINER'S AMENDMENT or No eclaration is deficient.	OTICE OF
st be submitted.		
	PTO-948) attached	
	· · · · · · · · · · · · · · · · · · ·	
	the Office action of	
.84(c)) should be written on the header according to 37 CFR	drawings in the front (not the 1.121(d).	back) of
sit of BIOLOGICAL MATER	NAL must be submitted. N	ote the
		•
5 Notice of Infor	mal Patent Application	
	''	
Paper No./Ma	ail Date	
	atement of Reasons for Allov	vance
9. U Other		
l R		
	Examiner Hoang V. Nguyen Pars on the cover sheet with (OR REMAINS) CLOSED in the or other appropriate community of the same propriate propriat	10/580,462

Application Number: 10/580,462 Page 2

Art Unit: 2821

Allowable Subject Matter

1. Claims 1-9 are allowed.

2. The following is an examiner's statement of reasons for allowance:

Regarding claim 1, Hansen et al (US 5,844,413) discloses a method for measuring a radiation pattern and a gain of a radiator. Hansen, however, fails to teach the specific steps of measuring powers of output port of a transverse electric and magnetic (TEM) waveguide by changing arrangements of the radiator located within the TEM waveguide; and estimating a radiation power density of the radiator in free space, wherein the radiator is modeled as a dipole moment based on the powers of the output port of the TEM waveguide.

Claims 2-9 are allowed for depending on claim 1.

3. Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

Conclusion

- 4. The prior art made of record and not relied upon is considered pertinent to applicant's disclosure. US 4,837,581 discloses a method of testing radiation pattern using a TEM waveguide.
- 5. Any inquiry concerning this communication or earlier communications from the examiner should be directed to Hoang V. Nguyen whose telephone number is (571) 272-1825. The examiner can normally be reached on Mondays-Fridays from 8:00 a.m. to 4:00 p.m..

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Douglas Owens can be reached on (571) 272-1662. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

6. Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free). If you would like assistance from a USPTO Customer Service Representative or access to the automated information system, call 800-786-9199 (IN USA OR CANADA) or 571-272-1000.

Hvn 9/7/07

HOANG V. NGUYEN PRIMARY EXAMINER